

#3 IPS
D/AV/G/T/02
PATENT - 9-01
P56640

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

YOUNG-BIN IM et al.

Serial No.: to be assigned

Examiner: to be assigned

Filed: 3 December 2001

Art Unit: to be assigned

For:

TENSION MASK ASSEMBLY FOR FLAT CATHODE RAY TUBE

INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner
for Patents
Washington, D.C. 20231

Sir:

In accordance with 37 C.F.R. §1.56, and §§1.97 and 1.98 as amended, Applicant cites, provides copies and discusses the following art references:

<u>U.S. Patent No.</u>	<u>Inventor</u>	<u>Date</u>
• 4,926,089	Moore	5/15/1990

Moore'089 discloses tied slit foil shadow mask with false ties.

The citation of the foregoing references is not intended to constitute an assertion that other or more relevant art does not exist. Accordingly, the Examiner is requested to make a wide-ranging and thorough search of the relative arts.

No fee is incurred by this Statement.

Respectfully submitted,



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Folio: P56640
Date: 3 December 2001
I.D.: REB/sb